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9-20-01
Harrison

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. SEP. 19, 2001 09/602,395
Filing Date TECHNOLOGY CENTER 2800 June 22, 2000
Inventor Moore, J.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Nguyen, T.
Attorney's Docket No. MI22-1384
Title: (As Amended) Methods of Forming Oxide Regions Over Semiconductor Substrates

Assistant Commissioner for Patents

Washington, D.C. 20231

ASSOCIATE POWER OF ATTORNEY

Please recognize Jennifer J. Taylor, Reg. No. P-48,711, whose post office address is 601 W. First Avenue, Suite 1300, Spokane, Washington 99201-3828, as an associate attorney or agent in the above-entitled application.

Date: 9/10/01

A handwritten signature in black ink, appearing to read "David Latwesen". It is positioned above a horizontal line.

David G. Latwesen, Ph.D.
Reg. No. 38,533

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